



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Kiyoshi IRINO**

Group Art Unit: **2815**

Serial No.: **09/428,052**

Examiner: **Jose R. Diaz**

Filed: **October 27, 1999**

Confirmation No.: **4139**

For: **METHOD OF FABRICATING A SEMICONDUCTOR DEVICE
CONTAINING NITROGEN IN A GATE-OXIDE FILM (As
Amended)**

Attorney Docket Number: **970901A**

Customer Number: **38834**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Date: February 9, 2005

Sir:

In compliance with 37 C.F.R. §1.56, Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached PTO/SB/08. A copy of each non-U.S. document is enclosed herewith. Also enclosed is a copy of the communication from a foreign patent office citing the listed documents

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Respectfully submitted,

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Enclosure: PTO/SB/08 and 5 Documents and Foreign Communication

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